

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/014,314	KELLER ET AL.
	Examiner Shih-Chao Chen	Art Unit 2821

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
343	742, 867	9/20/2005	CHEN
343	870	9/20/2005	CHEN